

Development of a high-performance gantry system for a new generation of optical slope measuring profilers

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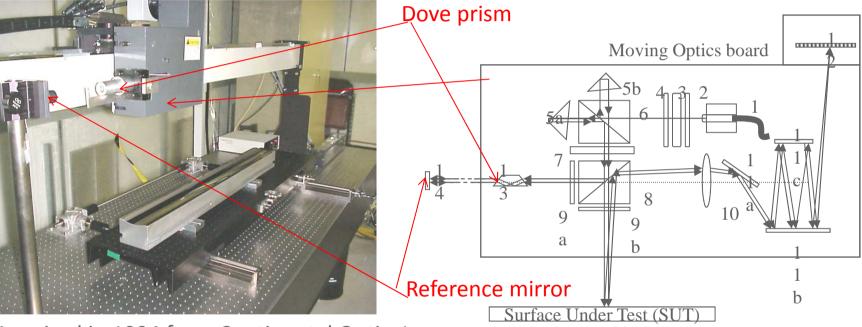




utline

- Motivation and goals
- Specification development
- Gantry system and motion control
- Enclosure and environment control
- Data acquisition and analysis software
- Preliminary tests and results
- Temperature survey
- Characterization of the gantry system
- Summary and future work

he APS Long Trace Profiler (LTP-II)



Acquired in 1994 from Continental Optic, Inc.

Dove prism added in the reference arm in 1996 to compensate for thermal drift

- Noise level is ≈ 0.3 urad.
- Systematic error >0.5 μ rad due to imperfections in the optical elements of the optics board.
- Non linearity

It is ready to retire!

step to upgrade APS LTP attempted in 2009-10 with modest budget and objective

-Pierre Rock* and Lahsen Assoufid , APS LTP -II Upgrade Conceptual Design ort, Internal Report, Argonne National Laboratory, 2010

nmer Student 2009 and 2010, University of Maryland

Table 2: Change in length as a function of temperature.

Scanning Pentaprism

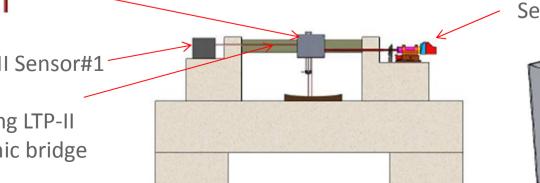


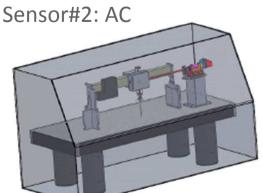
	ΔL (μm)		
Δ°C	Carbon steel		Cranita
	min	max	Granite
0.5	2.955	4.954	1.104
1.0	5.909	9.909	2.209

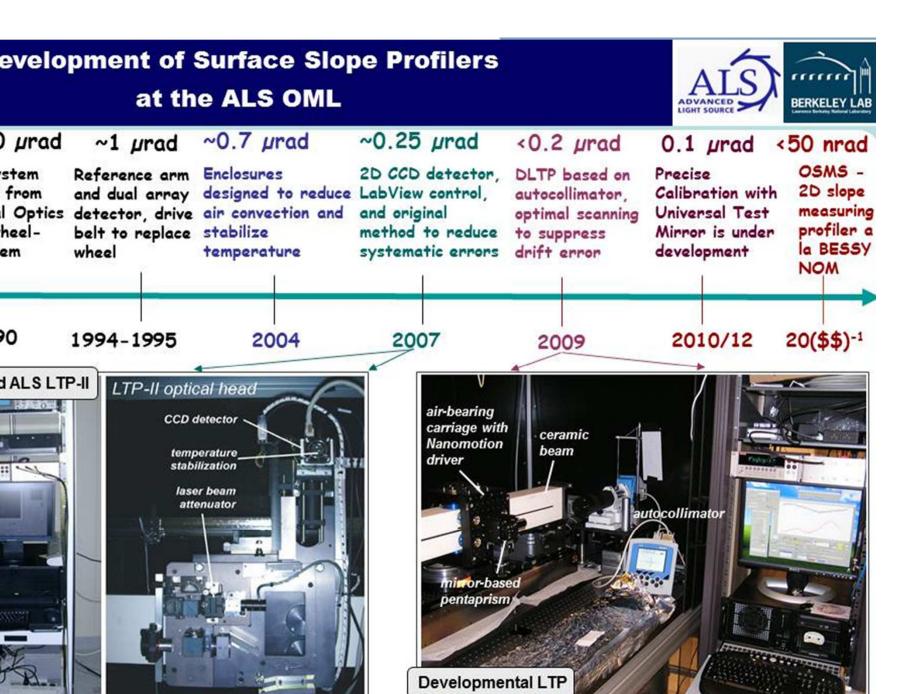


Diaphragm for the AC

Another addition to the system could be to place a thermal enclosure for the LTP within the existing thermal enclosure of the metrology laboratory to have a more precise temperature control. An illustration of future work is shown below.

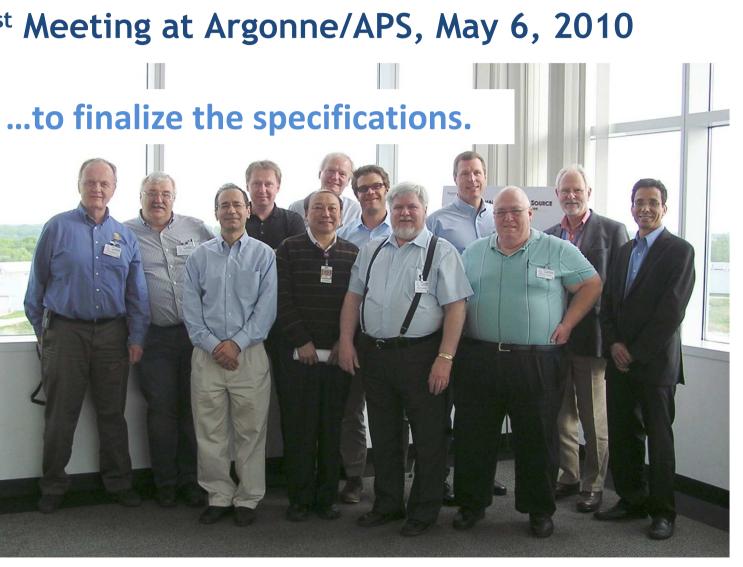






he Development of Specification for OSMS: ^{it} meeting at LBL/ALS, March, 26 2010

- Collaborative efforts of metrology groups at DOE Labs
- Active participation of industrial vendors of x-ray optics and metrology instrumentation and others
- Goals of the meeting:
- Discuss the development of new generation of optical slope measuring system (OSMS);
- Solidify the OSMS design approaches that will meet the needs of tight mirror specifications and also be affordable for all parties involved, both manufacturers and metrology labs; and
- Put together a common specification for fabrication of a high performance mterology gantry system for OSMS
 - Designed to accommodate multiple sensors to cover a wide range of measurement needs in 1-D and 2-D.
 - Capable of <50 nrad absolute accuracy



Valeriy V. Yashchuk, Peter Z. Takacs, Wayne R. McKinney, Lahsen Assoufid, Frank Siewert and Thomas Zeschke "Development of a new generation of optical slope measuring profiler,"

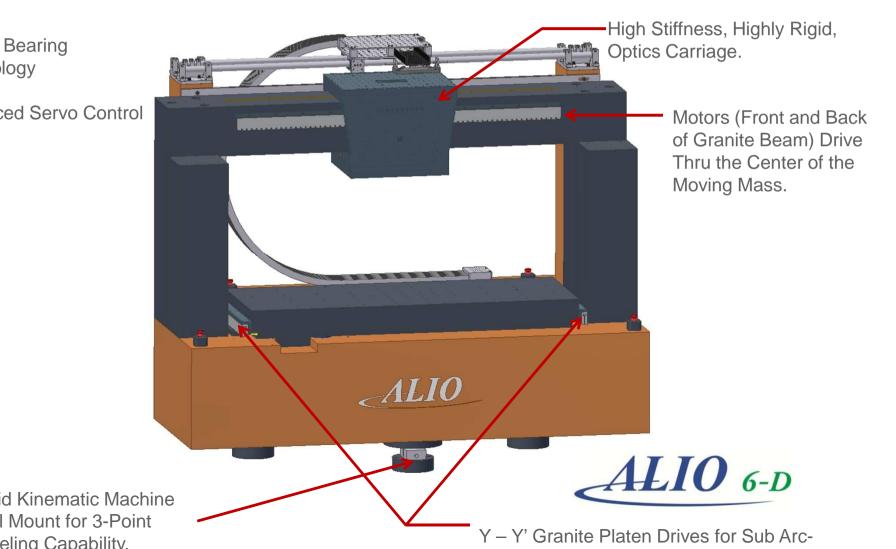
esign of the Gantry System

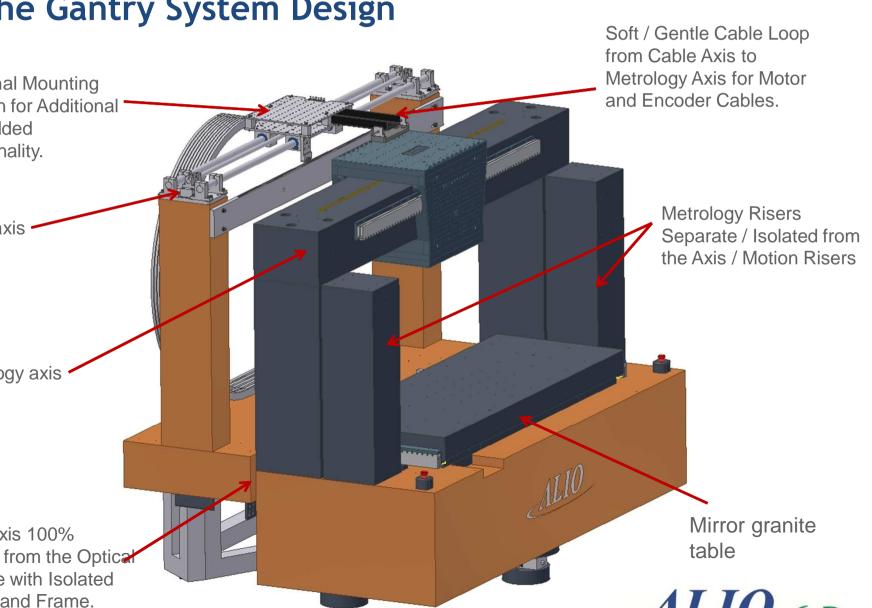
- Gantry system with two carriages operating is master-slave mode
 - One carriage for slope sensors
 - One carriage for long cables and air supply lines for the airbearing
 - Avoids cables torc and motion-induced perturbations
- High precision X-linear motor driven carriage with air bearing with 1.5 m scan range:
- 50 nm step size, 50 kg capacity
- High precision Y-linear motor driven mirror support table system with air bearing with 300 mm scan range:
- 50 nm step size, 100 kg capacity (to accommodate large mirror bender assemblies)
 Mirror kinematic support tip/tilt table with 180 degree rotation platform, fully motorized
- Tip/tilt with 1 urad step size
- Low thermal extension, highly stable granite

aleriy V. Yashchuk, Peter Z. Takacs, Wayne R. McKinney, Lahsen Assoufid, Frank Siewert and Thomas Zeschke "Development of a new generation of optical slope measuring ofiler," NIMA 649 (S1), 153-155 (2011).

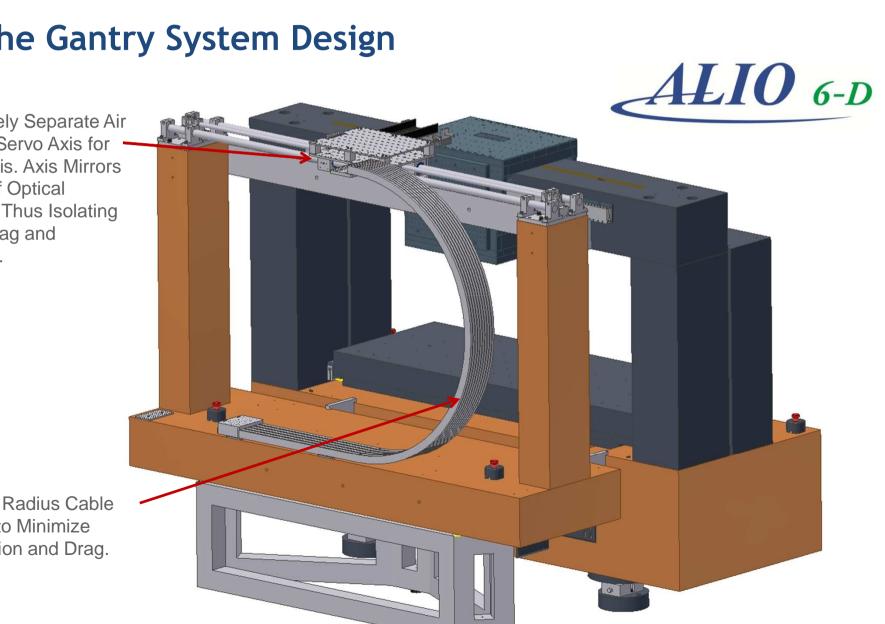
he Gantry System Design

tem with separate carriages: one the sensors and one for the cables





he Gantry System Design



Radius Cable o Minimize

ivery of the gantry system: August 2011



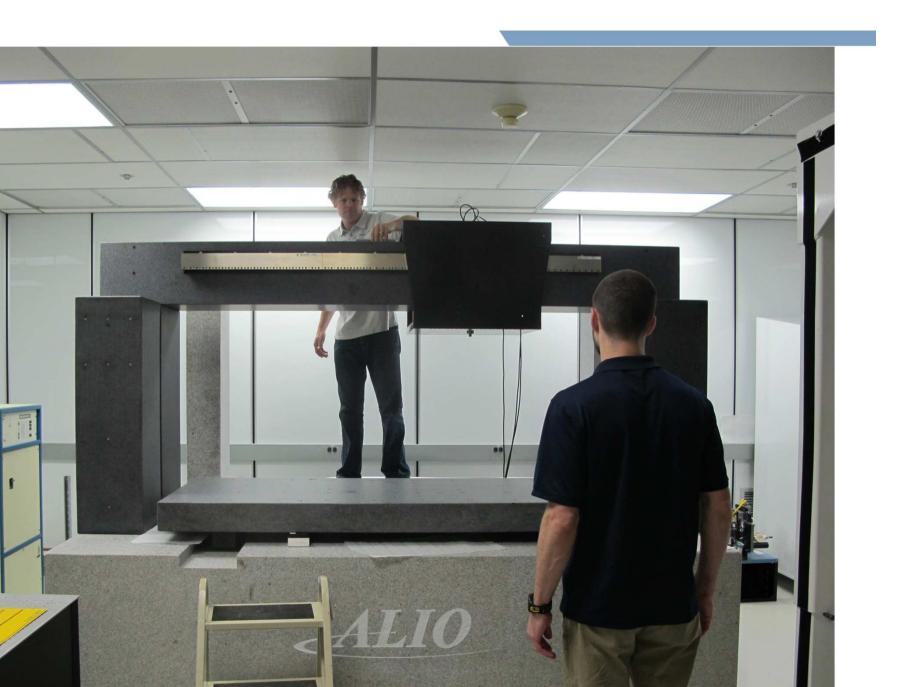










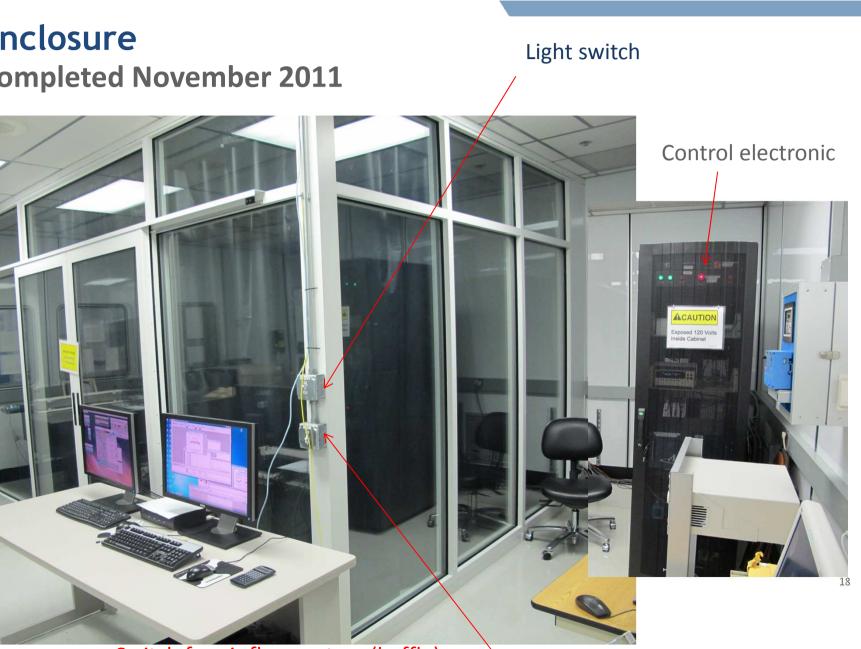


onstruction of the Enclosure (October 2011)



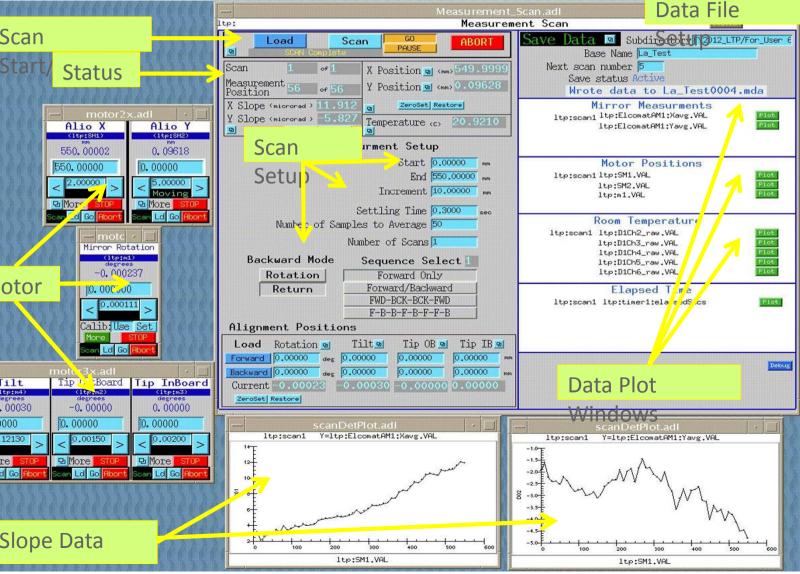


Granite table ' • • ...



Switch for air flow system (haffle)

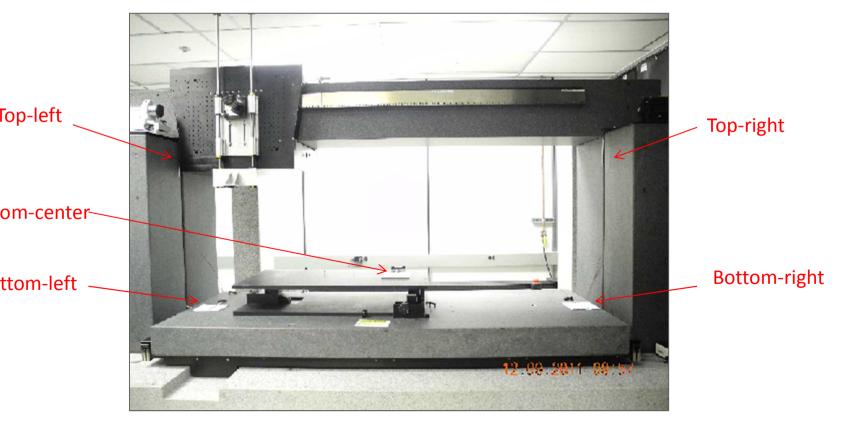
PICS-based Data Acquisition



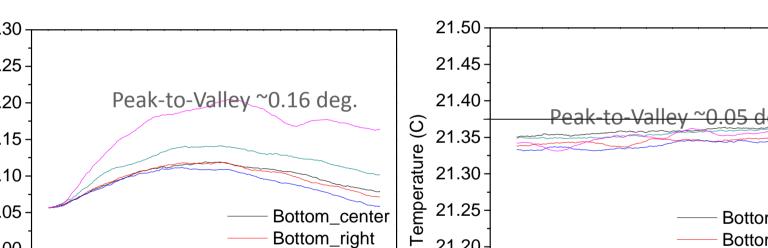
emperature monitoring and stability

Survey with both temperature point probes (placed around the measurement volume) and an IR Camera.

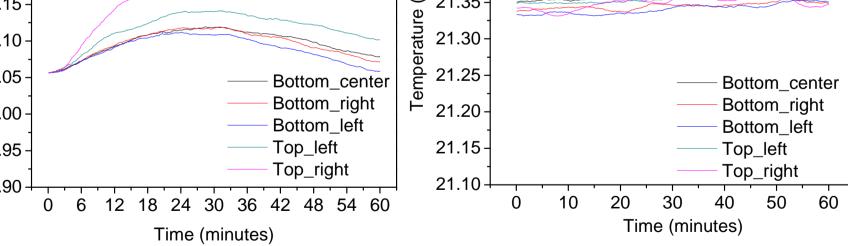
Measurements performed under various conditions and duration



irst temperature stability survey (January 2012)

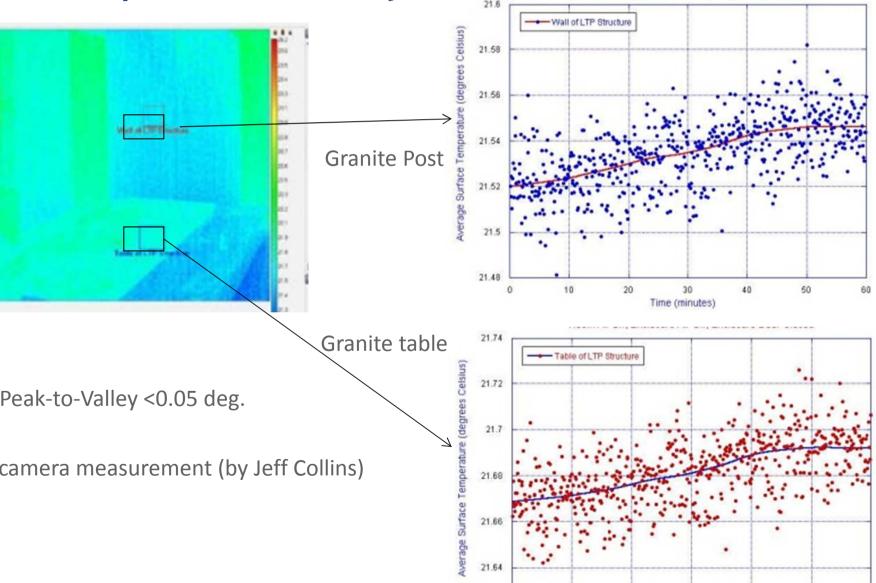


Measurement with temperature point probes over 60 minutes

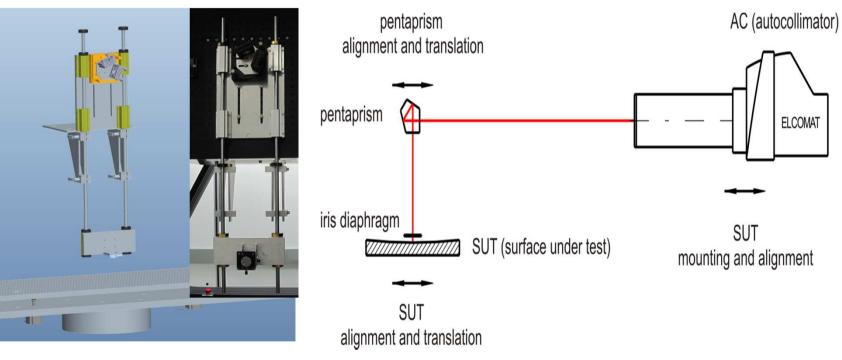


Room AC on; Enclosure AC on; Enclosure door closed Room AC on; Enclosure AC off; Enclosure door closed





eliminary tests performed using an AC and a mirror ntaprism (NOM concept)

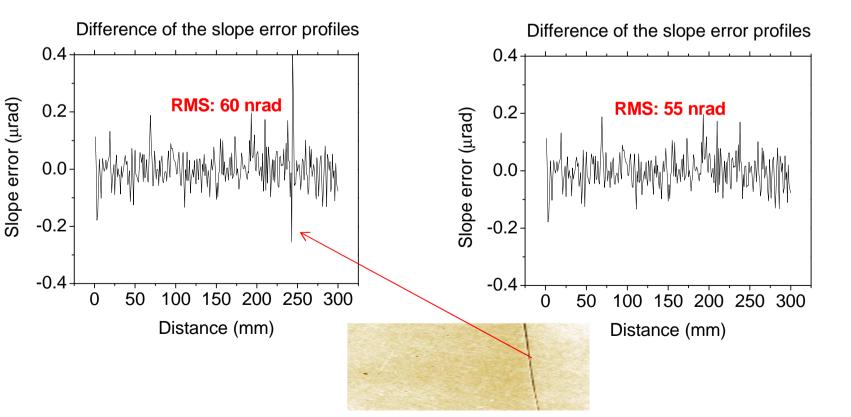


uary 2012: first measurements carried out using 350 mm Si mirror (see talk by Jun n on Friday)

y 2012: Characterization of the gantry system (carried out in collaboration with ALS) ewert, H. Lammert, T. Zeschke, Modern Developments in X-ray and Neutron Optics, ger 2008

eatability measurements on 350 mm flat Si mirror

ge spike due to defect in the mirror, ssibly for positioning error More representative with the large spike filtered ...

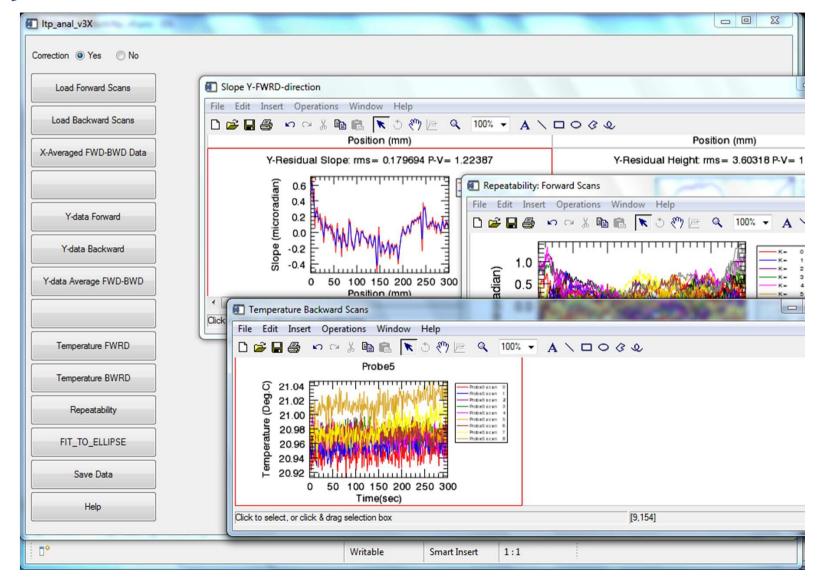


ted from J. Qian et al. Talk at this workshop)

sues to be addressed and Future Work

- Improve long term temperature stability
- Improve the data acquisition
- Develop the data analysis software
- Complete the comprehensive characterization tests initiated in May 2012 in collaboration with ALS
- Develop and integrate new slope sensors
- Develop standard calibration tools and methods
- A new series of worldwide Round robin measurements may be helpful
- Suggestion for further improvement are welcome!

nalysis Software



ummary

Ne developed a high-performance metrology gantry system with the goal to develop a new generation of optical slope measuring system (OSMS)

The system is designed to :

- be modular, with multi-functional translation/scanning capability
- accommodate multiple sensors to cover a wide range of measurement needs in 1-D and 2-D.
- achieve absolute accuracy <50 nrad

The first gantry system was built by ALIO Industries (USA) for APS and commissioned anuary 2012

Preliminary rounds of tests achieved satisfactory results:

 <70 nrad repeatability was obtained using the NOM configuration, thus meeting the APS goal for Phase-I of the development

Future work (Phase-II): Achieve <50 nrad absolute accuracy. This requires:

- Improving the temperature stability and data acquisition software
- Developing and implementing: 1) advanced sensors, 2) advanced calibration tools and methods, and 3) data analysis and processing software

These enhancements and others will contribute to the development of the next system to be acquired by ALS

cknowledgements

- If Geckler and Michael Shultz (PTB) : autocollimator calibration & useful interaction
- non Alcok (Diamond Light Source), Amparo Vivo (ESRF) and Haruhiko Ohashi pring-8) for useful interaction
- ka Bender and Curt Preissner (APS): Mechanical engineering
- f Collins (APS): Temperature survey
- nn Sidarous, Andy Stevens, Marvin Kirshenbaum (APS): Enclosure

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Thank you!

ktra Slides